

#8/B PB  
9/4/03IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	)	
Inventors: Hirohiko Nishiki	)	
Serial No.: 10/021,342	)	ATTORNEY FILE NO.
Filed: December 12, 2001	)	SLA 454
Title: SYSTEM AND METHOD FOR FORMING OZONE RESISTANT IC AND LCD STRUCTURES (as amended)	)	Customer No.: 27518
	)	Confirmation No.: 6170

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND REQUEST FOR RECONSIDERATION IN  
RESPONSE TO A NOTICE OF NON-COMPLIANT AMENDMENT

In response to a Notice of Non-Compliant Amendment dated August 6, 2003, please amend and reconsider as follows.

Amendments to the specification begin at page 2 of this paper.

The claims begin at page 3 of this paper.

Remarks begin at page 10 of this paper.